

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q91857

Hisaharu NISHIO, et al.

Appln. No.: 10/564,354

Group Art Unit: 2855

Confirmation No.: 8930

Examiner: Michael T. Cygan

Filed: January 12, 2006

For: GAS SENSOR AND METHOD OF PRODUCING GAS SENSOR

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Office Action of October 27, 2006, thus providing for timely filing by Monday, January 29, 2007, please amend the above-identified application as follows.

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